



- 1 -

Docket: 0756-2409

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of )  
KOICHIRO TANAKA )  
Serial No. 10/021,719 ) Group Art Unit: 2881  
Filed: 12/19/2001 ) Examiner: Unassigned  
For: LASER ANNEALING METHOD AND )  
SEMICONDUCTOR DEVICE )  
FABRICATING METHOD )

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Sir:

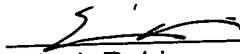
In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, Applicant submits herewith a Form PTO-1449 listing references known to Applicant and requests that these references be made of record in the above identified application. Copies of the references listed are submitted herewith in accordance with 37 C.F.R. 1.98(a).

U.S. Patents 5,854,803 and 6,210,996 are in the family of JP 8-195357.

This *Information Disclosure Statement* is being issued before the issuance of a first Office Action and therefore no fee is required.

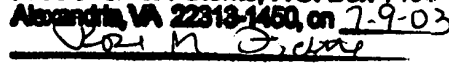
The Commissioner is hereby authorized to charge fees under 37 C.F.R. §§1.16, 1.17, 1.20(a), 1.20(b), 1.20(c), and 1.20(d) (except the Issue Fee) which may be required now or hereafter, or credit any overpayment to Deposit Account No. 50-2280. A duplicate copy of this sheet is attached.

Respectfully submitted,

  
Eric J. Robinson  
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Substitute for form 1449A/PTO

# **INFORMATION DISCLOSURE STATEMENT BY APPLICANT**

(use as many sheets as necessary)

## **Complete if Known**

Application Number	10/021,719
Filing Date	12/19/2001
First Named Inventor	Koichiro TANAKA et al.
Group Art Unit	2881
Examiner Name	Unassigned
Attorney Docket Number	740756-2409

Sheet 1 of 1

## **U.S. PATENT DOCUMENTS**

Examiner Initials <sup>5</sup>	Cite No. <sup>1</sup>	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code <sup>2</sup> (if known)			
		2003/0024905		Tanaka	02/06/2003	
		2003/0059990		Yamazaki	03/27/2003	
		6,160,827		Tanaka	12/12/2000	
		5,953,597		Kusumoto et al.	09/14/1999	
		6,204,099		Kusumoto et al.	03/20/2001	
		5,712,191		Nakajima et al.	01/27/1998	
		5,937,282		Nakajima et al.	08/10/1999	
		6,242,289		Nakajima et al.	06/05/2001	
		4,330,363		Biegesen et al.	05/18/1982	
		5,854,803		Yamazaki et al.	12/29/1998	
		6,210,996		Yamazaki et al.	04/03/2001	
		6,265,745		Kusumoto et al.	07/24/2001	

## **FOREIGN PATENT DOCUMENTS**

Examiner Initials <sup>5</sup>	Cite No. <sup>1</sup>	Foreign Patent Document			Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T <sup>6</sup>
		Office <sup>3</sup>	Number <sup>4</sup>	Kind Code <sup>2</sup> (if known)				
		JP	08-195357			07/30/1996		Abst.

## **OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS**

Examiner Initials <sup>5</sup>	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
		Hara et al., "Ultra-High Performance Poly-Si TFTs on a Glass by a Stable Scanning CW Laser Lateral Crystallization," AM-LCD '01, pp. 227-230	
		Takeuchi et al., "Performance of Poly-Si TFTs Fabricated by a Stable Scanning CW Laser Crystallization," AM-LCD '01, pp. 251-254	

Examiner Signature

Date Considered

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

<sup>1</sup> Unique citation designation number. <sup>2</sup> See attached Kinds of U.S. Patent Documents. <sup>3</sup> Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). <sup>4</sup> For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. <sup>5</sup> Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. <sup>6</sup> Applicant is to place a check mark here if English language Translation is attached.